# Epitaxial Growth of Ni-based Superalloys Using Laser and Spark Deposition

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**Abstract.** In this paper, epitaxial growth on Ni-based single cryst is was actuated by using spark deposition and laser powder deposition. Different Ni-based substate such as Ch 3X-4, TMS 138A as well as deposition materials: NiCrAl, Rene N4 and modifical 1.5<sup>th</sup> go tration single crystal alloys were used. The deposited layers were analysed by laser confocal microscient, FEG-SEM, X-ray and electron backscatter diffraction (EBSD), had very little filution and epitaxial growth was confirmed for the deposits made using Rene N4 electrodes. The deposition time at 100 V voltage, 850 W power and 110 Hz frequency was 3min and the layer thickness caried from 0.3 to 0.5 mm. Cracks were observed in certain areas with the formation of the grains. In one and ten layers were manufactured. The total layer thickness on substrates was 0.3 mm and 2 mm respectively. The processing parameters were: laser power of 500 W, laser bear to meter of 0.6 mm and the z displacement was equal to 80% of the layer height. The laser deposition also result d in successful epitaxial growth and minimal defects (pores or cracks), however and the content of the layer height dilution.

#### Introduction

Excellent performance at high teaperatures is of fundamental importance for highly efficient energy conversion and longer component service life of gas turbines. The principal requirements are adequate mechanical properties and microstructural stability at high temperature, and good oxidation/corrosion esistance [1]. The use of single-crystalline materials allowed increasing the environment emperature of critical components such as turbine blades and vanes in the hot section of gas turbines, adding to major advance in their energetic efficiency [1-3]. Today single crystalline components are essfully produced from Ni-based superalloys by investment casting [1-5], but this technique cannot be used for refractory alloys and intermetallics, due to their high melting temperature are poor castability.

The microstructure of the single crystal Ni-based superalloys is composed of an ordered FCC  $A_3B$  ( $\gamma'$  phase) intermetallic phase (A = Ni, B = Al, Ti) dispersed in a disordered matrix that consists of FCC Ni-based solid solution strengthened by substitutional Co, Cr, Mo, W, Ta and Re alloying elements ( $\gamma$  phase) [2,3]. The high temperature strength of the superalloys is controlled mainly by volume fraction, size, spacing and morphology of the intermetallic phase. The earliest precipitation strengthened material (e.g. Nimonic 80 and 90) contained about 10% by volume of the  $\gamma'$  phase compared to  $60 \sim 70 \text{ vol}\%$  in the modern single crystal superalloys (e.g. CMSX-4 and Rene 4) [4]. Aluminium and chromium are the most important elements that improve oxidation resistance by forming stable oxide scales e.g.  $Al_2O_3$  and  $Cr_2O_3$ . On the other hand, chromium tends to lower the  $\gamma'$  solvus temperature and is also responsible for the formation of undesirable embrittling topologically close-packed (TCP)

phases, such as  $\sigma$ ,  $\mu$ . In order to avoid these drawbacks, the amount of chromium was decreased in the second and third generation single crystal alloys. High temperature strength (high vol% of cuboid shaped  $\gamma$ ' phase) and good corrosion resistance (high vol% of Aluminium and Chromium) are conflicting requirements, difficult to optimise. Application of corrosion resistant coatings can overcome this conflict. The coatings should be single crystal to eliminate the diffusion short circuit through grain boundaries.

The high cost of single crystal turbine blades, vanes and seal segments is a major problem and developing a repair method capable of extending their lifetime is a matter of great economic interest. Conventional welding methods such as gas-tungsten-arc welding lead to stray grain formation and cracking [4], alternative repair methods are therefore required.

The coats produced by high-energy micro-arc alloying (HEMAA) are typically free cores and cracks and their oxidation resistance is usually better compared to coatings produced by ther methods [5]. HEMAA gives the possibility to generate coats with high density and almost ero porosity. In addition, it can be used to treat comparable small components artifor continents with complex geometry. Moreover, production of functional layers for new parts as well as recording processes of used parts is possible. Hence, HEMAA can be a competitive process to other coating techniques [6].

In Laser Powder Deposition (also referred to as Direct Metal Deposition or Laser adding), an object is formed layer by layer by injecting powder into the laser-generate pelt pool while scanning the laser beam under CN control, according to a CAD model the process llows rapid and accurate addition of controlled amounts of material at desired locations with in fimum heat input, thus enabling crack-sensitive materials such as Ni-base alles to be deposited. By controlling the laser power density, laser scan speed and processing paramers, it is possible to deposit single crystal layers free of defects (cracks or pores). As a result, lase, wder deposition presents considerable potential as a method for high temperature-resis component manufacturing and repair [7-8]. In the present work, two techniques: spark deposition and wder deposition, were used to deposit epitaxial layers onto single crystal substrates. Both techniques are compared and their advantages and disadvantages are highlighted.

## **Experimental procedure**

High-energy micro-arc alloging was performed using a MD-WKD-1500 1.5kw constructed in the laser processing research center CPRC), Wuhan University of Science & Technology. The alloying was carried out by a hand-held prin room temperature with argon protection. HEMAA was performed at 100 %, 850 V and 100 Az. The revolving electrode was successively in traveling contact with the substrate prace to form thick Ni20Cr12Al and Rene N4 layers. The Rene N4 electrodes were produced by Nam Welding, Japan, by plasma transferred arc (PTA) technique. The base plate dimensions were 20min 15mm×3mm and the surface area was effectively covered within 3 minutes. The same rate overe made from CMSX-4 single crystal Ni-based superalloy. The composition of the material content of the second Table 1.

A Truedic 1006 laser (max power of 4 KW and wavelength of 1030 nm) from Trumpf equipped with a TGV's double hopper powder feeder, a three beam coaxial powder nozzle and Kuka's KR-60HA robot arm was used for the laser deposition experiments. The deposits were made at laser power of 500 W, powder feed rate 1 g/min and laser 4mm/s scanning speed. The powder material was a modified 5th generation alloy of high Re and Ru content and the substrate was made of TMS 138A. The composition of the powder and substrate can be seen in Table 2.

The clad microstructure and crystallography were analysed by laser confocal microscope Keyence VK9700, Hitachi FEG-SEM SU6600 equipped with EDAX SDD XR-EDS and TSL Digiview electron backscatter diffraction detector. The EBSD measurements were performed at different step sizes ranging from 50 nm to 5  $\mu$ m and probe current 7 nA. The crystallography of both the layers and the substrate was also analysed by X-ray diffraction using a Bruker D8 discover with GADDS. The

X-ray tube equipped with Cu or Cr radiation was operated at 40 kV/40 mA and 35 kV/40 mA, respectively. A graphite monochromator was used at the incident beam. The distance of the 2D detector and the X-ray tube source was 15 cm, this corresponds to a  $\pm 15^{\circ}$  range from the centre of the detector.

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Table I	Substrate and	nowder jised	tor snark	denosition
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wt%	Ni	Cr	Со	Мо	W	Al	Ti	Та	Hf	Re	Nb	Fe	С
CMSX-4	61.8	6.5	9.0	0.6	6.0	5.6	1.0	6.5	0.1	3	n.a.	n.a.	n.a.
Rene N4	61.5	9.8	7.6	1.6	6.1	4.4	3.4	4.9	0.17	n.a.	0.5	0.08	0.06

Table 2 Substrate and powder used for laser deposition

wt%	Ni	Cr	Co	Мо	W	Al	Ti	Та	Hf	Re	Ku	С	В
TMS-138A	61.8	3.2	5.8	2.8	5.6	5.7	n.a	5.6	0.1	5	3.6	n.a.	ıı.a.
modTMS	59.6	3.9	5.1	3.0	5.9	6.2	0.7	5.2	0.18	2		0.0	0.05

## **Experimental results and discussions**

The spark deposited layers made by using NiCrAl and dene N4 alloys can be seen in Figure 1. The layers were from 100 to 300 µm thick. It is posssible to be very good metallurgical bonding of layers with no porosity, however a few cracks can be observed, the layers made by using NiCrAl material had very high texture as shown in the X-ray difference tion pattern. Figure 2, however many stray grains could be observed as in the orientation imagine than the properties of a notice of stalline nature as shown in Figure 4. The misorientation profiles along the substrate and from the bottom to the top of the deposited layer are shown in Figure 4b and 4c respectively. The highest "point-to-origin" misoriention was 1.8° and 3° for the substrate and deposited layer are shown in Figure 4b and 4c respectively. The highest "point-to-origin" misoriention was 1.8° and 3° for the substrate and deposited layer are case of the deposite made with NiCrAl, the misorientation profile in the substrate shown a 18° maximum "point-to-origin" misorientation.

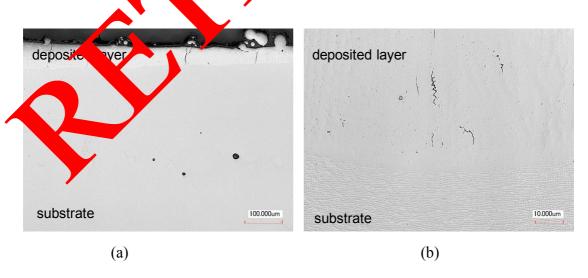


Figure 1 Cross section of spark deposited layers: (a) NiCrAl layer (b) Rene N4 layer.

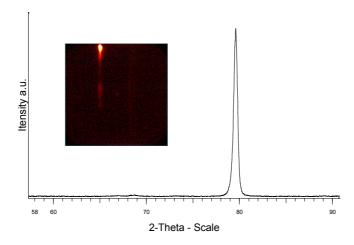


Figure 2 Diffraction pattern of NiCrAl layer showing high (100) texture of the departed lay Collimator size is 20 µm.

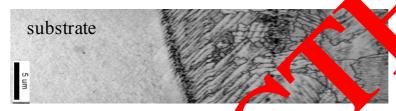


Figure 3 OIM (image quality map) shoring strain grain formation close to the substrate/spark deported layer interface.

NiCrAl deposited onto CMSX-4 layer deposition.

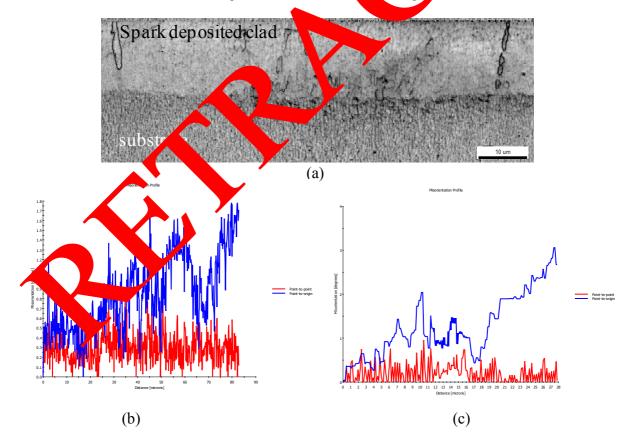


Figure 4 OIM measurements of Rene N4 deposits onto CMSX-4 substrate: (a) image quality (b) misorientation profile along the substrate (max 1.8°) (c) misorientation profile from the substrate to the spark deposited layer top (max 3°).

Figure 5 shows the one-layer clad made by laser powder deposition onto TMS 138A substrates. The processing parameters were: laser power 500 W, laser beam diameter 2 mm, powder feed rate 1 g/min and laser scanning speed 4 mm/s. The clad shows almost no pores or cracks but high dilution and consequently high heat affected zone (HAZ) were observed. High dilution can be avoided by using lower power, higher powder feed rate and/or faster scanning speed [5, 9-12]. The substrate-laser deposited layer interface can be seen in Figure 5b. The planar front solidfication and dendritic growth can be clearly observed. The formation of a plane solidification front region at the bottom of track occurred due to the large temperature gradient (G) and low solidification rate (R) that existed in the bottom of the melt pool, during the first stage of solidification [5]. The solid-liquid interface rapidly evolves to a dendritic interface as solidification proceeds, due to the rapid decrease of the G/R ratio, which leads the formation of a constitutional undercooling region ahead of the S/L interface.

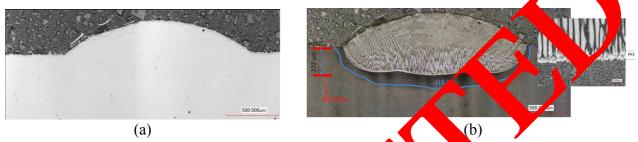


Figure 5 LCM cross section micrographs of one-layer modTMS for deposite imples onto TMS 138A substrate: (a) polished surface (b) etched sample and micrograph detail to the interface.

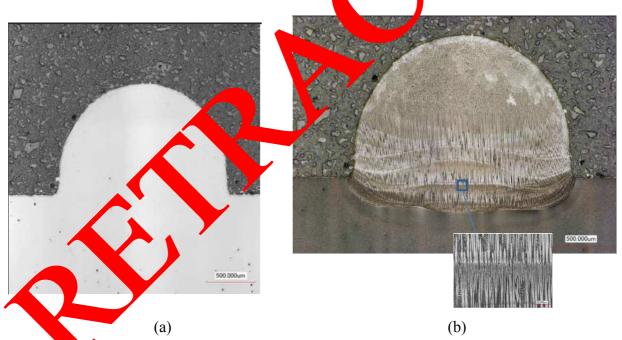


Figure 6 section of multiple build-up of modTMS alloy after laser powder deposition onto TMS 138A substrate: (a) polished and (b) etched sample. See detail of the layer-to-layer interface

During multiple-layer deposition, the previous layer is partially remelted when the following one is deposited, and this way epitaxial growth and crystallographic orientation are maintained across the successive layers. For adequate range of processing parameters, the columnar dendritic structure is preserved from layer to layer as well. As a result, multilayers present a dendritic structure where dendrites grow throughout the layers, as observed in Figure 6, an LCM micrograph of a multilayer sample deposited in [100] direction and a (001) surface substrate. The clads had very good metallurgical bonding and no pores or minimum cracks were observed.

### **Conclusions**

Spark deposition and direct metal laser deposition were used to produce thick layers onto CMSX-4 and TMS 138A single crystal substrates. Both techniques showed a potential to produce single crystal clads by epitaxial forming onto single crystal substrates. The processing parameters for spark deposition still need to be optmised in order to avoid cracking and in the case of laser forming - to avoid high dilution. Laser deposition can produce thicker layers, however the initial cost of the machine significantly higher than the cost of a spark deposition device. Laser deposition is expected to be applicable when large areas require repair, while spark deposition can be used to formation of NiCrAl coatings or minor repair work.

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